

IFW

03500.017456

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: H. M. Lee
KAZUHIRO KAGAMI ET AL.	)	
	:	Group Art Unit: 2823
Application No.: 10/627,645	)	
	:	
Filed: July 28, 2003	)	
	:	
For: BASE PATTERN FORMING	)	
MATERIAL FOR ELECTRODE	:	
AND WIRING MATERIAL	)	
ABSORPTION, ELECTRODE	:	
AND WIRING FORMING	)	
METHOD, AND METHOD OF	:	
MANUFACTURING IMAGE	)	
FORMING APPARATUS	:	March 1, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUPPLEMENTAL AMENDMENT

Sir:

A. Introductory Comments

Further to the Amendment filed on February 27, 2006, please amend the application as follows and consider the following remarks.